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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/713,572
Filing Date: November 12, 2003
Applicant: Kazuaki Sakurada
Group Art Unit: 1762
Examiner: Unknown
Title: MULTILAYER CIRCUIT BOARD,
MANUFACTURING METHOD THEREFOR,
ELECTRONIC DEVICE,
AND ELECTRONIC APPARATUS
Attorney Docket: 9319G-000593

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL INFORMATION DISLCOSURE STATEMENT

Upon review of the Form 1449 accompanying applicant's IDS mailed September 30, 2005, it was determined that a typographical error existed. The Japanese foreign patent document listed as Item 11. should be **02-148880**. Accordingly, a Supplemental Form 1449 is enclosed.

EV 717 344 741 US

Favorable consideration of this application is respectfully requested.

Respectfully submitted,

Dated: Oct 27, 2005

By: 

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FORM HDP-1449 (Based on Form PTO-1449)

**PATENT AND TRADEMARK OFFICE
INFORMATION DISCLOSURE CITATION**

(Use several sheets if necessary)

Sheet 1 of 1

ATTORNEY DOCKET NO.

9319G-000593

SERIAL No.

10/713,572

APPLICANT

Kazuaki Sakurada

FILING DATE

November 12, 2003

GROUP

1762

FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation *	
						Yes	No
1.		2003-309369	Oct/2003	Japan		X	
2.		2003-523070	July/2003	Japan			X
3.		WO 99/53738	Oct/1999	WIPO		Abstract	
4.		11-163499	June/1999	Japan		X	
5.		10-221698	Aug/1998	Japan		X	
6.		09-008454	Jan/1997	Japan		X	
7.		08-236908	Sept/1996	Japan		X	
8.		07-231154	Aug/1995	Japan		X	
9.		07-040445	Feb/1995	Japan		X	
10.		04-352387	Dec/1992	Japan		Abstract	
11.		02-148880	June/1990	Japan		Abstract	
12.		63-164392	July/1988	Japan			X
13.		**07-108206	April/1995	Japan			

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
1.		Communication from Japanese Patent Office regarding related application.

*One or more of the English translation documents submitted herewith may be Abstracts only or partial machine created translations from the Japanese Patent Office. As such, the submitter does not necessarily vouch for their accuracy. Additional information may be obtained from the Japanese Patent Office web site at www.jpo.go.jp

** This cited reference was previously filed with an Information Disclosure Statement.

Examiner:

Date Considered:

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.